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THE UNITED STATES PATENT AND TRADEMARK OFFICE

Attorney Docket No. 017498/0170

Applicant: Hisashi ISOZAKI et al.
Title: SURFACE INSPECTING APPARATUS AND METHOD
Application No.: 10/669,706
Filing Date: September 25, 2003
Examiner: Nguyen, Tu U.
Art Unit: 2877

AMENDMENT AND REPLY UNDER 37 C.F.R. 1.111

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This communication is responsive to the Non-Final Office Action dated May 3, 2004, concerning the above-referenced patent application.

Amendments to the Abstract are presented as a new Abstract attached to this document for insertion after the claim pages of the application. A marked-up version of the Abstract is also attached to this document, to show the changes made to the originally-filed Abstract

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this document.

Remarks/Arguments begin on page 8 of this document.

Please amend the application as follows: